



Itw

**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Takeshi KIJIMA et al.

Application No.: 10/724,635

Filed: December 2, 2003

Docket No.: 117926

For: METHOD OF MANUFACTURING OXIDE THIN FILM, METHOD OF  
MANUFACTURING FERROELECTRIC THIN FILM, FERROELECTRIC THIN  
FILM, FERROELECTRIC MEMORY DEVICE, AND FERROELECTRIC  
PIEZOELECTRIC DEVICE

**PRELIMINARY AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Please consider the following:

Amendments to the Specification; and

**Remarks.**